IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:	)	
	)	Examiner: Zarneke, David A.
Adrien KIERMASZ	)	
	)	Group Art Unit: 2891
Application No. 10/743,923	)	
	)	Atty. Docket No: LAM2P452
Filed: December 22, 2003	)	
	)	Date: October 5, 2005
For: LINEAR CHEMICAL MECHANICAL	)	
PLANARIZATION (CMP) SYSTEM AND	)	
METHOD FOR PLANARIZING A WAFER	)	
IN A SINGLE CMP MODULE	)	

SUPPLEMENTAL RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant submits this paper response to the Office Communication dated September 27, 2005. In the Office Communication, the Examiner alleges that Applicant's response to the restriction requirement set forth in the Office Action dated June 21, 2005, is incomplete because it does not address the election of species requirement. The election of species requirement set forth in the Office Action applied only if the Group I claims were elected (see the Office Action at page 3). In light of Applicant's election of the Group III claims in the Response to Restriction Requirement filed on July 21, 2005, the election of species requirement set forth in the Office Action does not apply. Accordingly, Applicant has fully responded to the restriction requirement.

Applicant respectfully requests examination on the merits for the subject application. If any fees are due to effect consideration of this paper, then the Commissioner is authorized to charge such fees to Deposit Account No. 50-0805 (Order No. LAM2P452).

Respectfully submitted,
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